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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

, nr						Docket N	lo.: AMD-0	30439	
bearing Fir	ertify that this s st Class Post	transmittal of the below de age and addressed to the (scribed document Commissioner for I	is being dep Patents, P.C	osited with the Un D. Box 1450, Alexa	ited States Pos	tal Service in a	n envelope	
of deposit. Date of Deposit:	12/15/03	Name of Person Making the Deposit:	Judy Davenp		ignature of the Per laking the Deposit:		1000	Coon	
		maning the Deposit.			laking the Depocie	100	1	100	
Inventor(s):		Nian Yang, Zhigang Wang, and Tien-Chun Yang							
Serial No.:		10/017,832 Group Art Unit: 2829							
Filed:		12/12/2001		Exa	aminer:	Kobert,	Russell	Marc	
Confirmation No:		5028							
Title:		MÊTHOD OF DETERMINING GATE OXIDE THICKNESS OF AN OPERATIONAL MOSFET							
P.O. Bo		Patents 2313-1450					•		
Sir:	• *								
		<u>TI</u>	RANSMITTAL	OF FORI	MAL DRAWIN	<u>GS</u>			
In response to Drawing Informalities									
at X (a)	tached ple) the for	ease find: mal drawings for this Number of Sheets	application 5						
	Each sheet of drawing indicates the identifying indicia suggested in § 1.84(c) on the reverse side of the drawing								
(b) a copy of the NOTICE OF INFORMAL DRAWINGS									
	<i>A</i> .								
Please o	direct all c	orrespondence cond	erning the ab	ove-iden	tified application	on to the fo	llowing add	dress:	
	•	,	San Jose	arket Stre	eet, Third Floo nia 95113				
F					Respectfully submitted,				
Date:	12/	15/03		By:_	John P. W Reg. No.	Vagner, Jr. 35,398		_	